

L Number	Hits	Search Text	DB	Time stamp
1	2	("5834334" or ("5712609")).PN. "9927325"	USPAT	2003/01/15 10:58
-	3		EPO; JPO; DERWENT	2003/01/12 11:51
-	1	1999-328283.NRAN.	DERWENT	2003/01/10 16:30
-	0	9927325.URPN.	USPAT	2003/01/10 16:31
-	0	thermal with membran with sensor	USPAT	2003/01/10 16:32
-	157	thermal with membrane with sensor	USPAT	2003/01/10 16:33
-	5	thermal near2 membrane near2 sensor	USPAT	2003/01/10 17:03
-	4	micromechanical near2 membrane near2 sensor	USPAT	2003/01/10 17:04
-	264	micromechanical near2 sensor	USPAT	2003/01/10 17:05
-	104641	silicon near2 (nitride carbide dioxide) (thermal or micromechanical) near2 sensor	USPAT	2003/01/13 09:21
-	5612	(428/156).CCLS.	USPAT	2003/01/12 11:54
-	1389	(silicon near2 (nitride carbide dioxide)) and ((thermal or micromechanical) near2 sensor )	USPAT	2003/01/12 11:54
-	619	428/\$3.\$2.cccls.	USPAT	2003/01/12 11:55
-	35645	((silicon near2 (nitride carbide dioxide)) and ((thermal or micromechanical) near2 sensor )) and 428/\$3.\$2.cccls.	USPAT	2003/01/12 11:56
-	1	membrane near2 senor	USPAT	2003/01/13 09:20
-	1543	membrane near2 sensor	USPAT	2003/01/13 09:21
-	104641	silicon near2 (nitride carbide dioxide) (membrane near2 sensor) and (silicon near2 (nitride carbide dioxide) )	USPAT	2003/01/13 09:21
-	194		USPAT	2003/01/13 11:11